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	Application No.	Applicant(s)	_
Notice of Allowability	10/602,738	HATANO ET AL.	
	Examiner	Art Unit	
	Stanetta D. Isaac	2812	
	Ctanetta D. Isaac	2012	
The MAILING DATE of this communication apperall claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI	(OR REMAINS) CLOSED in this a or other appropriate communication. GHTS. This application is subject	pplication. If not included on will be mailed in due course. TH	
1. X This communication is responsive to 06/25/03.			
2. 🔀 The allowed claim(s) is/are <u>1-23</u> .			
3. $igotimes$ The drawings filed on <u>25 June 2003</u> are accepted by the E.	xaminer.		
4. $igtimes$ Acknowledgment is made of a claim for foreign priority un	der 35 U.S.C. § 119(a)-(d) or (f).		
a) ⊠ All b) ☐ Some* c) ☐ None of the:			
 Certified copies of the priority documents have 	been received.		
Certified copies of the priority documents have	been received in Application No.		
Copies of the certified copies of the priority do	cuments have been received in thi	s national stage application from th	е
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:			
 Acknowledgment is made of a claim for domestic priority ur reference was included in the first sentence of the specifica 	nder 35 U.S.C. § 119(e) (to a prov ttion or in an Application Data She	isional application) since a specific et. 37 CFR 1.78.	
(a) The translation of the foreign language provisional a	• •		
 Acknowledgment is made of a claim for domestic priority ur in the first sentence of the specification or in an Application 		since a specific reference was inclu	ıdec
Applicant has THREE MONTHS FROM THE "MAILING DATE" of below. Failure to timely comply will result in ABANDONMENT of the comply will result in ABANDONMENT of the complex will be a supplyed to the complex will result in ABANDONMENT of the complex will be a supplyed to the complex	this communication to file a reply this application. THIS THREE-MO	complying with the requirements no	oted BLE
7. A SUBSTITUTE OATH OR DECLARATION must be submi	itted. Note the attached EXAMINE es reason(s) why the oath or decla	R'S AMENDMENT or NOTICE OF ration is deficient.	
3. CORRECTED DRAWINGS (as "replacement sheets") mus	t be submitted.		
(a) ☐ including changes required by the Notice of Draftspers		D-948) attached	
1) hereto or 2) to Paper No			
(b) including changes required by the proposed drawing co	orrection filed, which has	peen approved by the Examiner.	
(c) \square including changes required by the attached Examiner's			
Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the	84(c)) should be written on the draw ne margin according to 37 CFR 1.12	vings in the front (not the back) of 1(d).	
9. DEPOSIT OF and/or INFORMATION about the deposattached Examiner's comment regarding REQUIREMENT FOR T	sit of BIOLOGICAL MATERIAL HE DEPOSIT OF BIOLOGICAL M	must be submitted. Note the ATERIAL.	
Attachment(s)			
1⊠ Notice of References Cited (PTO-892)	5☐ Notice of Informal F	Patent Application (PTO-152)	
2☐ Notice of Draftperson's Patent Drawing Review (PTO-948)	6☐ Interview Summary	(PTO-413), Paper No	
BIX Information Disclosure Statements (PTO-1449 or PTO/SB/08		· · · · · · · · · · · · · · · · · · ·	
Paper No ↓☐ Examiner's Comment Regarding Requirement for Deposit			
of Biological Material	o⊠ Examiner's Statem 9☐ Other	ent of Reasons for Allowance	

DETAILED ACTION

EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The application has been amended as follows: Claim 1 line 14, following interval modulated by scanning the laser beam delete—or and insert—on.

Allowable Subject Matter

- 2. Claims 1-23 are allowed.
- 3. The following is an examiner's statement of reasons for allowance: Applicant's independent claim 1 is allowed over the prior art of record because none teach or render obvious a method for fabricating an image display device comprising an active matrix substrate having a pixel region formed with a large number of pixels arranged as a matrix and a drive circuit region formed with an active circuit for supplying a drive signal to said pixels from outside said pixel region, the method comprising the steps of:
- 4. selectively irradiating a portion of the polycrystalline silicon film located in said drive circuit region with a laser beam having a pulse width and /or a pulse interval modulated by scanning the laser beam on the substrate to form discrete reformed regions each composed of a quasi-strip-like-crystal silicon film resulting from reformation, said quasi-strip-like-crystal silicon film having a crystal boundary continuous in the direction of scanning. See Voustas US Patent 6,664,147 where Voustas teaches a semiconductor method where a polycrystalline silicon

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film is formed having a crystal boundary continuous in the direction of scanning, however fails the step where the laser beam on the substrate to form discrete reformed regions each composed

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of a quasi-strip-like-crystal silicon film resulting form reformation.

5. All dependent claims are also rendered allowable.

6. Any comments considered necessary by applicant must be submitted no later than the

payment of the issue fee and, to avoid processing delays, should preferably accompany the issue

fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for

Allowance."

7. Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Stanetta D. Isaac whose telephone number is 703-308-5871. The

examiner can normally be reached on Monday-Friday 7:30am -5:30pm.

8. If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, John Niebling can be reached on 703-308-3325. The fax phone number for the

organization where this application or proceeding is assigned is 703-308-7722.

9. Any inquiry of a general nature or relating to the status of this application or proceeding

should be directed to the receptionist whose telephone number is 703-308-0956.

Stanetta Isaac Patent Examiner January 11, 2004

Supervisory Patent Examiner
Technology Center 2800